



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date June 23, 2008

In re the Application of

Takaaki NODA et al.

Group Art Unit: 1792

Application No.: 10/587,500

Examiner: K. STOUFFER

Filed: July 27, 2006

Docket No.: 128807

For: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE AND APPARATUS FOR PROCESSING SUBSTRATE

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired May 22, 2008, an extension of time for a period of 1 month is hereby requested. Attached hereto is our Check No. 206995 in the amount of \$120 in payment for:

X Extension fee for response within first month pursuant to §1.136(a) (\$120.00)  
\_\_\_\_\_ Extension fee for response within second month pursuant to §1.136(a) (\$460.00)  
\_\_\_\_\_ Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1050.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

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**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry;  
Charge any fee due to our  
Deposit Account No. 15-0461